Accurate, Reliable, Cost Effective,

Emissions Monitoring for Compliance & Process Improvement



LasIR[™] Laser-based Cross-stack Gas Monitor For US-EPA & TÜV Compliance, Fenceline & Process Monitoring NH₃, HCl, O₂, CO, H₂O, HCN, H₂S, CO₂, CH₄, HF, HDO, D₂O, ...

Features & Benefits

- TDL (Tunable Diode Laser) technology for unmatched accuracy & reliability
- High sensitivity ppb to percent level measurements ٠
- One analyzer can be used for up to 16 measurement points
- Performance designed Process Monitor
 - In-situ: Gas sampling/conditioning not required
 - Corrosive/toxic applications
 - Calibration not required
 - Inline/Offline Audit option available
- Exceeds US-EPA CEMS Regulation requirements •
 - MACT & MATS PS-18 Compliant
 - Boiler MACT O₂ and CO Compliance
 - Approved Zero & Span Calibration checks
 - Extremely Fast (<1 second) response time
- Compact and simple to install •
- Ambient conditions from -40° to 70° C
- Operates in high dust/moisture applications •
- Unaffected by stack/duct alignment changes
- Laser located in controller allowing for simple signal control and diagnostic access
- Moisture can be added as a second channel
- Off Stack/Process extractive option
- Hazardous Area Div I & II options



Product Description

Unisearch LasIR[™] Gas Analyzer is a continuous monitor designed to measure flue gases for both compliance and process monitoring. The Controller uses a near infrared (NIR) Tunable Diode Laser Absorption Spectrometer System utilizing a single mode laser mounted in a thermoelectric cooler for unsurpassed accuracy and performance. Since the spectral purity of the laser is high and the selected absorption feature is unique,

laptop PC or the client's existing data acquisition system.

Typical Applications:



Power

- HCI: EPA MATS Compliance Monitoring per PS18
- NH₃ & H₂O: Gas Fired Slip Monitoring for Process Control & EPA compliance
- NH₃: Coal Fired slip monitoring for prevention of air preheater fouling & corrosion
- $\bullet~O_2\,\&\,CO:\,Combustion\,Control\,and\,Optimization$

Cement

- HCI: EPA PC MACT Compliance Monitoring per PS18
- CO, CO₂, O₂: Process Monitoring

Refining:

• CO, CO₂, O₂, H₂S, NH₃: FCC, SRU, Furnaces & Heaters

Petrochemical:

- HF, H₂S, CO, CO₂, O₂, NH₃, Trace H₂O: SRU, Reform & Cracker Chemical
- CO, CO₂, O₂, HF, HCl, H₂O, NH₃, HCN: Process gases **Nitric Acid Production**

• NH3

Aluminum Smelters:

• HF in Stack, Open path in Pot rooms, Fence line monitoring

Steel Smelters

- CO, CO₂, O₂, H₂O
- Nickel Smelters
- H₂S, CO, CO₂, O₂

Gold Smelters

• HCN

Pulp & Paper

H₂S

Nuclear Processing

• HF, D₂O, HDO

Incinerators

• HF, HCl, NH₃, O₂, CO, CO₂

Nylon, Carbon fibers, Plastics

• HCN, O₂

Wastewater Treatment

• H₂S, CH₄

Ceramic/Brick

• HF, HCl

Landfill

• H₂S, CH₄, NH₃

Tobacco Processing

• CO, CO₂ as early fire detection

Airport

• CO, CO₂, O₂ **Fertilizer**

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• HF, NH₃ Pharmaceutical

- HF. HCl. NH₃
- Semiconductor
- HF, NH₃, H₂O



Analyzer Specifications:

Laser: NIR Tunable Diode laser Telecommunication grade lasers for longevity, reliability and availability

Response Time: <1 second

Detection Limits: NH₃ < 0.5 ppm-m / HCl < 0.3 ppm-m / HF <0.1 ppm-m. Consult Factory for other gases

Environmental Conditions: -10 to +45°C, 5 – 95% RH, 800 – 1,200 mbar

Calibration: Factory Test results sent with every unit Internal reference cell, external portable audit module, or in-line flow through cell

Gas Temperature & Pressure Compensation Analog Inputs: 4-20 mA for each measurement point

Outputs and Networking:

Minimum two 4-20mA Analog Outputs for each measurement point, Ethernet, Six Dry-Contact NC & NO Status Relays

Dynamic Range: 5 orders of magnitude

Data Logging and Displaying Software: LasIRView (with Data Review and Statistical Analysis)

Data Storage: Internal storage & External storage via Ethernet or RS232 to an external computer or TCP/IP MODBUS

Power Supply:

Input 100 – 240 VAC @50-60Hz Output: 12VDC, 60w, Operating Voltage/Current: +12 VDC/1A

Analyzer Dimensions (Standard 19" rack-mount): 5.25" (H) x 17" (W) x 11" (D) (13 x 43 x 28 cm) ~11 lb (~5 kg)

Stack/DuctOptics:

Base: 12" (H) x 10" (W) x 10" (D) / ~11 lb (~5 kg) NEMA 4x Fiberglass-Composite Enclosure (316SS Enclosure Optional)

Mounting: 4" ANSI (9" OD, Class 150) flanges, additional sizes optional.

Air Purge Requirements: – *depending on conditions* 50 psi @ 25-50 L/min

Environmental Conditions:

Gas: -100 to +1,100 °C, 5-95% RH, 25-2,000 mbar Optics: -40 to 70°C, 5-95% RH, 25-2,000 mbar Detector up to 90°C



Available in 2, 4, 8, 12 & 16-channel configurations

DISTRIBUTORS WORLDWIDE

